## CONFERENCES, SYMPOSIA, WORKSHOPS, TRAINING PROGRAMMES AND EVENTS ORGANISED BY NPL

### August 2 – 4, 2005
Temperature & Humidity Standards Group has been peer reviewed by the International Technical Expert, Dr. J. Fischer from PTB, Germany.

### August 17-19, 2005
Organized Training Courses on "Mass Metrology", in which 44 participants from NABL accredited laboratories, Industries and other agencies have participated.

### September 13, 2005
Training Programme on "Evaluation and Expression of Uncertainty in Measurements".

### September 14, 2005
Training Programme on "Surface Roughness and Roundness Measurements".

### September 14-15, 2005
Training Programme on "Temperature Metrology" organized jointly by NPL & NABL.

### October 23 - 29, 2005
XXVIth General Assembly on International Union of Radio Science (URSI).

### September 8-10, 2005
Training Programme on "Temperature Metrology" organized jointly by NPL & NABL.

### December 13-17, 2005
XIII International Workshop on the Physics of Semiconductor Devices (IWPSD-2005). It was organized by NPL in collaboration with the Society for Semiconductor Devices. The Workshop was preceded on 12 December 2005 by two tutorials, (i) Advances in Photovoltaics and (ii) A course in Nano-Technology.

### December 19 – 23, 2005
Conducted a course on “Radio Metrology and Radio Wave Propagation over the sea”.

### January 16 – 17, 2006
A training course on “AC Voltage and Current Measurement, Standards and Calibration Techniques” was conducted for the trainees of NTH, Kolkata and ERTL (North).

### January 19 - 20, 2006
National Symposium (in Hindi) on “Atmospheric and Environmental Sciences”.

### January 23, 2006
A half day seminar on “Use of Vector Network Analyzer in Material Measurements” by Dr. Stoyan Ganchev of Agilent Technologies, USA.

### January 24-25, 2006
Meeting to review the status of the BND Programme. Nearly 50 scientists had attended the meeting.

### February 14-15, 2006
Training Programme on Pressure & Vacuum Metrology, organized jointly by NPL and NABL.

### February 22 – 24, 2006
35th National Seminar on “Crystallography”.

### February 27-28, 2006
Training programme on “IntelliSuite” software for MEMS design and simulation.

### February 28 - March 3, 2006
National Workshop and Training Course on “Coordinate Metrology”, organized jointly by NPL and MSI.